

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Prior Application: R. TAKEMURA et al
Serial No. 10/354,122
Filed: January 30, 2003

Group Art Unit: 2818
Examiner: G. Auduong
For: SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

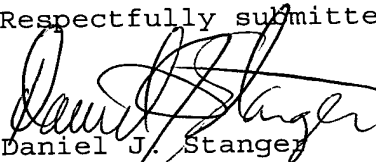
October 2, 2003

Sir:

In accordance with the duty of disclosure, the Applicants inform the Examiner of the documents cited during prosecution of the parent application, USSN 10/354,122.

The Applicants request the Examiner to initial and return a copy of the attached PTO-1449 form as an indication that the references have been considered.

Respectfully submitted,


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Date: October 2, 2003

FORM PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. NIT-243-04		SERIAL NO.	
LIST OF DOCUMENTS CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT R. TAKEMURA et al			
				FILING DATE 10/02/03		GROUP 2818	
U.S. PATENT DOCUMENTS							
* EXAMINER INITIAL		DOCUMENT	DATE	NAME	CLASS	SUBCLASS	FILING DATE (If Appropriate)
	AA	5,691,933	11/25/97	Takenaka			
	AB	5,396,450	03/07/95	Takashima et al			
	AC	5,838,038	11/17/98	Takashima et al			
	AD	6,043,562	03/28/00	Keeth			
	AE	6,222,275	04/24/01	Keeth			
	AF	6,243,311	06/05/01	Keeth			
	AG	4,903,344	02/1990	Inoue			
	AH	5,014,241	05/1991	Asakura et al			
	AI	6,400,596	06/2002	Takemura et al			
	AJ	6,426,889	07/2002	Sekiguchi et al			
	AK	6,538,912	03/2003	Takemura et al			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
	AL	5-41081	02/19/93	Japan			<input type="checkbox"/> <input type="checkbox"/>
	AM	9-135004	05/20/97	Japan			<input type="checkbox"/> <input type="checkbox"/>
	AN	0717414	06/19/96	Europe			<input type="checkbox"/> <input type="checkbox"/>
	AO	8-288471	11/01/96	Japan			<input type="checkbox"/> <input type="checkbox"/>
	AP	8-314112	11/29/96	Japan			<input type="checkbox"/> <input type="checkbox"/>
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	AR	ULTRA MICRO-FABRICATION TECHNOLOGY, The Japan Society of Applied Physics,					
		G. Tokuyama, 1st Edition issued by Ohm Co., Ltd., 2/25/97, pp. 27-41					
	AS						
	AT						
EXAMINER				DATE CONSIDERED			